

FILE COPY #7
CPK
RAB
2/8/01

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

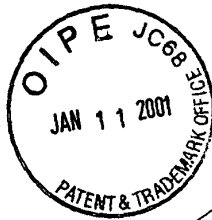
Hideki KOMATSUDA

Application No.: 09/697,639

Docket No.: 105193.01

Filed: October 27, 2000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATION
A MICRO-DEVICE USING THE EXPOSURE APPARATUS



REQUEST FOR CORRECTION OF PALM RECORDS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Thomas J. Pardini
Registration No. 30,411

RECEIVED
FEB 23 2001
TC 2800 MAIL ROOM

Date: January 11, 2001

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

FILE COPY



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov



Bib Data Sheet

SERIAL NUMBER 09/697,639	FILING DATE 10/27/2000 RULE —	CLASS 355	GROUP ART UNIT 2851	ATTORNEY DOCKET NO. 105193.01
APPLICANTS Hideki Komatsuda, Kawasaki-shi, JAPAN;				
** CONTINUING DATA ***** THIS APPLICATION IS A CIP OF 09/259,137 02/26/1999 27				
** FOREIGN APPLICATIONS ***** JAPAN 10-047400 02/27/1998) 27 JAPAN 10-263673 09/17/1998) JAPAN 2000-05137 02/25/2000) 056137				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/05/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>R. J. J.</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 21	TOTAL CLAIMS 46
			INDEPENDENT CLAIMS 4	
ADDRESS Oliff & Berridge PLC P O Box 19928 Alexandria ,VA 22320				
TITLE Exposure apparatus and method of fabricating a micro-device using the exposure apparatus				
FILING FEE RECEIVED 1258	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	



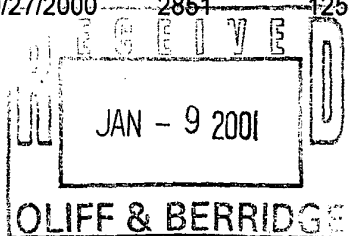
UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

MAC
105193.01

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/697,639	10/27/2000	2851	1258	105193.01	21	46	4

Oliff & Berridge PLC
P O Box 19928
Alexandria, VA 22320



FILING RECEIPT



OC000000005658399

Date Mailed: 01/05/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Hideki Komatsuda, Kawasaki-shi, JAPAN;

Continuing Data as Claimed by Applicant

THIS APPLICATION IS A CIP OF 09/259,137 02/26/1999

Foreign Applications

JAPAN 10-047400 02/27/1998
JAPAN 10-263673 09/17/1998
JAPAN 2000-500437 02/25/2000
2000-050137

If Required, Foreign Filing License Granted 01/05/2001

Title

APPARATUS
Exposure apparatus and method of fabricating a micro-device using the exposure apparatus

Preliminary Class

355

Data entry by : NIMMONS, EVELYN

Team : OIPE

Date: 01/05/2001

